

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
APPLN. OF: ONO ET AL
FILED: August 27, 2001
FOR: RESIN ENCAPSULATED BGA-TYPE SEMICONDUCTOR DEVICE
DOCKET: NEC 01341

#3 105
11-20-01
R. Stokes

06/27/01

BOX PATENT APPLICATION
The Commissioner of Patents & Trademarks
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicants hereby attach U.S. Patent Office Form PTOL-1449, including copies of the prior art references listed therein together with the English language abstracts. These references are discussed in the specification. The claims in the present application are believed to be patentably distinguished over these references.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitute prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,



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INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

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Docket Number (Optional)

NEC 0134

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Applicant(s)

Applicant(s)

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Group Art Unit

U.S. PATENT DOCUMENTS

JC 79 U.S. PRO
19/910249 08/27/01

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2-240940	9/25/90	JAPAN W/ABSTRACT	H01L	21/56		✓
	10-116935	5/6/98	JAPAN W/ABSTRACT	H01L	23/28		✓
	11-195733	7/21/99	JAPAN W/ABSTRACT	H01L	23/28		✓

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.